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APR -9 2002

TECHNOLOGY CENTER 2800

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2851**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenji NISHI

Group Art Unit: 2851

Application No.: 08/994,758

Examiner: A. Mathews

Filed: December 19, 1997

Docket No.: 110157.99

For: PROJECTION EXPOSURE APPARATUS

#34/f
DMS
5/30/02
JPC

AMENDMENT AFTER FINAL REJECTION IN REISSUE APPLICATION

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Please enter AM
In reply to the Office Action dated January 3, 2002, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

IN THE CLAIMS:

Please replace claim 37 as follows:

Sub v4
37. (Three Times Amended) A scanning exposure apparatus in which a first object is moved in a first direction and a second object is moved in a second direction for scanning exposure, the apparatus comprising:

a projection system for the scanning exposure, which is disposed in an optical path of an exposure beam, the first object being provided on one side of the projection system and the second object being provided on the other side of the projection system;

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